

Notice of References Cited	Application/Control No. 10/658,483		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Simon A. Goetze		Art Unit 2617	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2003/0036384 A1	02-2003	Chen et al.	455/437
*	C	US-6,519,461 B1	02-2003	Andersson et al.	455/453
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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